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 then used to etch the Ni. 45. Fe. 55. thin film in the same chamber alloy mesa structure;
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(WO/2002/037541) ETCH CHAMBER FOR ETCHING DIELECTRIC LAYER WITH ...
 Figure 2 is a cross sectional view of one embodiment of an etch chamber 100 of the
 magnet system just described has a U-shaped cross section as shown ...
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 chamber with computer control unit. The RF power to plasma source is ... Fig.3 cross
 section of high etch rate > 10 $\mu\text{m}/\text{min}$ on 100 feature size with > 400 μm ...
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 in a vacuum chamber, wherein the etching process with argon gas is ... 5 is a cross-
 section view of a portion cut along line V--V of FIG. 4; ...
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FIGURE 1 Pre-etch cross-section of a typical FRAM module. consumer products. ... the magnetic field through the dielectric chamber window, resulting in a ...

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